

Notice of References Cited

Application/Control No.

09/434,736

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

Evan T. Pert

Art Unit

2813

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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	U	Fink and Christensen, ELECTRONIC'S ENGINEERS' HANDBOOK, 1989, McGraw-Hill Book Company, Third Edition, pages 8-18 to 8-19.
X	V	Wolf, SILICON PROCESSING FOR THE VLSI ERA VOLUME 2: PROCESS INTEGRATION, 1990, Lattice Press, Chapter 4, pages 176-297.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.